

FEK3214 MEMS- Seminar IV 2.0 credits

MEMS-seminarie IV

This is a translation of the Swedish, legally binding, course syllabus.

If the course is discontinued, students may request to be examined during the following two academic years

Establishment

Course syllabus for FEK3214 valid from Autumn 2012

Grading scale

Education cycle

Third cycle

Specific prerequisites

Language of instruction

The language of instruction is specified in the course offering information in the course catalogue.

Intended learning outcomes

After the completed course the student shall be able to:

• Report on various ongoing international researches in MEMS.

- Describe application examples and/or commercial applications of MEMS.
- Review various applications and research of MEMS outside the student's own research field.
- Compare ongoing research to other efforts in the field and be able to assess research novelty in a scientific context.

Course contents

The course consists of seminars given by internal or external lecturers. Lectures will cover topics such as current MEMS research presented at international conferences, commercial applications of MEMS or other topics related to MEMS research and application.

Disposition

Seminars, given at several occasions per year.

Course literature

N/A

N/A

Equipment

None

Examination

Based on recommendation from KTH's coordinator for disabilities, the examiner will decide how to adapt an examination for students with documented disability.

The examiner may apply another examination format when re-examining individual students.

Other requirements for final grade

Active participation at at least ten seminars is required.

Ethical approach

- All members of a group are responsible for the group's work.
- In any assessment, every student shall honestly disclose any help received and sources used.

• In an oral assessment, every student shall be able to present and answer questions about the entire assignment and solution.